

Application/Control No.	Applicant(s)/Patent under Reexamination	Applicant(s)/Patent under Reexamination	
10/736,627	KANNO, HIROSHI		
Examiner	Art Unit		
Stochan E Jones	2917		

SEARCHED				
Class	Subclass	Date	Examiner	
333	238,246, 247,172, 32, 33	2/10/2005	SJ	
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
AII	Above	4/12/05	81	
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
Consulted J. Bettendorf	2/8/2005	SJ		
consulted Benny Lee	11/3/2004	SJ		
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